Facsimile

Charles M. Marmelstein

marmelstein.c@arentfox.com

202.857.6008 DIRECT 202.857.6395 FAX

Date:

November 15, 2006

Pages (including cover): 2

Attorney #:

1546

Client/Matter #:

025720-00020

PLEASE DELIVER TO:

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Verify #

Mr. Lewis

Certificates of Correction

U.S. Patent & Trademark Office

703-308-6672

703-305-8309

MESSAGE/INSTRUCTIONS

Re:

Request for Duplicate Certificate of Correction

U.S. Letters Patent No.: 6,933,810 B2

Issued: August 23, 2005 By: Michio MIURA et al Our Ref: 025720-00020

Dear Mr. Lewis:

Enclosed please a Request for Duplicate Certificate of Correction for the above-identified U.S. Letters Patent. If you should have any questions or need any additional information, please do not hesitate to contact us.

Respectfully submitted

Charles M. Marmelstein

Reg. No. 25,895

PLEASE CALL OUR FAX OPERATOR AS SOON AS POSSIBLE IF TRANSMISSION IS NOT COMPLETE: 202.857.6119

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Arent Fox PLLC

WASHINGTON DC

NEW YORK

1050 Connecticut Avenue, NW Ste 400 Washington, DC 20036-5339 202.857.6000 PHN 202.857.6395 FAX www.arentfox.com

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Letters Patent of:

Michio MIURA et al

Letters Patent No.: 6,933,810 B2

Issued: August 23, 2005

SURFACE ACOUSTIC WAVE DEVICE WITH LITHIUM

TANTALATE ON A SAPPHIRE SUBSTRATE AND FILTER

USING THE SAME

REQUEST FOR DUPLICATE CERTIFICATE OF CORRECTION

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

November 15, 2006 (via facsimile)

ATTN: Certificates of Correction

Sir:

It is respectfully requested that a duplicate Certificate of Correction be issued in the subject U.S. Letters Patent. The undersigned has checked the records of the U.S. Patent and Trademark Office and discovered that a Certificate of Correction issued on March 14, 2006. To date, the undersigned has not received this Certificate of Correction. In checking the records of the U.S. Patent and Trademark Office, the undersigned has noted that the correct mailing address is of record. Therefore, it is respectfully requested that a duplicate Certificate of Correction be issued in this U.S. Letters Patent.

In the event that any fees are due with respect to this paper, please charge Deposit Account No. 01-2300, referencing Atty. Docket No. 025720-00020.

Respectfully submitted.

Charles M. Marmelstein Registration No. 25,895

Atty. Docket No.: 025720-00020

Customer No. 004372 Arent Fox PLLC 1050 Connecticut Avenue, N.W. Suite 400 Washington, D.C. 20036-5339 Tel (202) 857-6000 Fax (202) 638-4810

CMM:mmg

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO. : 6,933,810 B2 DATED : August 23, 2005

INVENTOR(S) : Miura et al.

Page 1 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page,

Item [73], Assignee, add the following:

-- Fujitsu Media Devices Limited, Yokohama (JP) --.

Item [57], ABSTRACT, amend as follows:

-- A surface acoustic wave device includes a piezoelectric substrate having a first surface on which comb-like electrodes are formed, and a second surface, and a support substrate joined to the second surface of the piezoelectric substrate. The piezoelectric substrate is made of lithium, tantalate, and the support substrate is made of sapphire. The following expressions being satisfied:

T/t < 1/3

T/λ>10

where T is a thickness of the piezoelectric substrate, t is a thickness of the support substrate, and λ is a wavelength of an IDT forming a resonator including the comb-like electrodes propagated along the first surface of the piezoelectric substrate.

Column 2,

Lines 50-53, should read:

-- where T is a thickness of the piezoelectric substrate, t is a thickness of the support substrate, and λ is a wavelength of an IDT forming a resonator including the comb-like electrodes propagated along the first surface of the piezoelectric substrate. --.

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO.

: 6,933,810 B2

DATED

: August 23, 2005

INVENTOR(S) : Miura et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 2, line 66 to Column 3, line 2,

-- where T is a thickness of the piezoelectric substrate, t is a thickness of the Should read: support substrate, and λ is a wavelength of an IDT forming a resonator including the comb-like electrodes propagated along the first surface of the piezoelectric substrate. --.



Signed and Sealed this

Page 2 of 2

Fourteenth Day of March, 2006



JON W. DUDAS Director of the United States Patent and Trademark Office